Ref #	Hits	Search Query	DBs	Default Operator	Plurals	Time Stamp
S1	435	OFET	US-PGPUB; USPAT; USOCR; EPO; JPO; DERWENT; IBM_TDB	OR	ON	2007/04/30 14:39
S2	5195832	@ad>"20030114"	US-PGPUB; USPAT; USOCR; EPO; JPO; DERWENT; IBM_TDB	OR _	ON	2007/04/30 14:40
S3	167	S1 not S2	US-PGPUB; USPAT; USOCR; EPO; JPO; DERWENT; IBM_TDB	OR	ON .	2007/05/01 17:42
S4	1	("7064345").PN.	US-PGPUB; USPAT; USOCR	OR	OFF	2007/04/30 14:43
S5	3	(("6197663") or ("6326288") or ("6362509")).PN.	US-PGPUB; USPAT; USOCR	OR	OFF	2007/04/30 14:57

S6	66	US-20020022284-\$.DID. OR	US-PGPUB;	OR	ON	2007/04/30 14:58
		US-20020053320-\$.DID. OR	USPAT;			
		US-20020056839-\$.DID. OR	USOCR			
		US-20020068392-\$.DID. OR				
1		US-20020170897-\$.DID. OR				
		US-20020018911-\$.DID. OR				
		US-20020195644-\$.DID. OR				
		US-20030112576-\$.DID. OR				
		US-20040002176-\$.DID. OR				
		US-20040013982-\$.DID. OR				
}		US-20040026689-\$.DID. OR				
	ļ	US-20040084670-\$.DID. OR				
		US-20040211329-\$.DID. OR				
		US-3512052-\$.DID. OR				·
		US-3769096-\$.DID. OR				
		US-3955098-\$.DID. OR				
		US-4302648-\$.DID. OR				
		US-4442019-\$.DID. OR				
		US-4926052-\$.DID. OR				
		US-4865197-\$.DID. OR				
		US-5173835-\$.DID. OR				
		US-5206525-\$.DID. OR				
		US-5259926-\$.DID. OR				
		US-5321240-\$.DID. OR			ļ	
	·	US-5347144-\$.DID. OR			1	
		US-5395504-\$.DID. OR				
		US-5480839-\$.DID. OR		·		
		US-5486851-\$.DID. OR				
		US-5502396-\$.DID. OR				1
		US-5546889-\$.DID. OR				
		US-5569879-\$.DID. OR				
		US-5574291-\$.DID. OR				
•		US-5578513-\$.DID. OR	•	}		
		US-5580794-\$.DID. OR		İ		
		US-5629530-\$.DID. OR				·
		US-5630986-\$.DID. OR		[	1	
		US-5652645-\$.DID. OR				
		US-5691089-\$.DID. OR				
		US-5854139-\$.DID. OR				
		US-5869972-\$.DID. OR				
		US-5892244-\$.DID. OR				
		US-5946551-\$.DID. OR				
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		US-5967048-\$.DID. OR US-5973598-\$.DID. OR				
		US-5973598-\$.DID. OR US-5997817-\$.DID. OR				
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		US-6036919-\$.DID. OR				
		US-6045977-\$.DID. OR		1		
		US-6060338-\$.DID. OR				
		US-6083104-\$.DID. OR				
		US-6133835-\$.DID. OR				
		US-6207472-\$.DID. OR				
		US-6215130-\$.DID. OR				
		US-6251513-\$.DID. OR				
		US-6284562-\$.DID. OR				
1/22/20	08 9:08:01 AM	US-6300141-\$.DID. OR				Page 2
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		110 6340033 + DID OR				

	T	T	Т	Τ"		
S7	14047	organic with transistor	US-PGPUB; USPAT; USOCR; EPO; JPO; DERWENT; IBM_TDB	OR	ON	2007/05/02 21:06
S8	5198781	@ad>"20030114"	US-PGPUB; USPAT; USOCR; EPO; JPO; DERWENT; IBM_TDB	OR	ON	2007/05/01 17:42
S9	4118	S7 not S8	US-PGPUB; USPAT; USOCR; EPO; JPO; DERWENT; IBM_TDB	OR	ON	2007/05/01 17:42
S10	2323	(257/40).CCLS.	US-PGPUB; USPAT; USOCR	OR .	OFF	2007/05/01 17:42
S11	244	S9 and S10	US-PGPUB; USPAT; USOCR; EPO; JPO; DERWENT; IBM_TDB	OR	ON	2007/05/01 17:43
S12	14047	organic with transistor	US-PGPUB; USPAT; USOCR; EPO; JPO; DERWENT; IBM_TDB	OR	ON	2007/05/02 21:06
S13	154	S12 and interdigita\$6	US-PGPUB; USPAT; USOCR; EPO; JPO; DERWENT; IBM_TDB	OR	ON	2007/05/02 21:08
S14	5198781	@ad>"20030114"	US-PGPUB; USPAT; USOCR; EPO; JPO; DERWENT; IBM_TDB	OR	ON .	2007/05/02 21:08

CIT	70	C12+ C14	LIC DCDLID	OD	ON	2007/05/02 21:00
S15	79	S13 not S14	US-PGPUB; USPAT; USOCR; EPO; JPO; DERWENT; IBM_TDB	OR .	ON	2007/05/02 21:08
S16	1	("6197663").PN.	US-PGPUB; USPAT; USOCR	OR	OFF	2007/05/02 22:10
S17	1	("6362288").PN.	US-PGPUB; USPAT; USOCR	OR	OFF	2007/05/02 22:10
S18	1	("6326288").PN.	US-PGPUB; USPAT; USOCR	OR	OFF	2007/05/02 22:10
S19		(US-20010045593-\$ or US-20010048379-\$).did. or (US-6545291-\$ or US-6362509-\$ or US-6326288-\$ or US-6870182-\$ or US-5970318-\$ or US-6852555-\$ or US-5079595-\$ or US-6433357-\$ or US-6818920-\$ or US-3999122-\$ or US-5535231-\$ or US-6806815-\$ or US-6870186-\$ or US-6197663-\$).did.	US-PGPUB; USPAT	OR	ON	2007/05/09 20:43
S20	5	S19 and "interdigitated"	US-PGPUB; USPAT	OR	ON	2007/05/09 20:43
S21	1434	(photodiode or (photo adj diode)) same (trench or hole) and (impurity or (separation adj region))	US-PGPUB; USPAT; USOCR; EPO; JPO; DERWENT; IBM_TDB	OR	ON	2007/05/10 15:27
S23	912	(photodiode or (photo adj diode)) same ((trench or hole) and (impurity or (separation adj region)))	US-PGPUB; USPAT; USOCR; EPO; JPO; DERWENT; IBM_TDB	OR	ON	2007/05/10 20:04
S24	1	S23 and @ad<"2003"	US-PGPUB; USPAT; USOCR; EPO; JPO; DERWENT; IBM_TDB	OR	ON	2007/05/10 13:47

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S25	430	S23 and @ad<"20030101"	US-PGPUB; USPAT; USOCR; EPO; JPO; DERWENT; IBM_TDB	OR	ON	2007/05/10 14:50
S26	0	"rose.kiesha.xa"	US-PGPUB; USPAT; USOCR; EPO; JPO; DERWENT; IBM_TDB	OR	ON	2007/05/10 13:59
S27	178	rose-kiesha.xa.	US-PGPUB; USPAT; USOCR; EPO; JPO; DERWENT; IBM_TDB	OR	ON	2007/05/10 14:04
S28	133817	S27 and photodiode or photodetector or (photo adj diode)	US-PGPUB; USPAT; USOCR; EPO; JPO; DERWENT; IBM_TDB	OR	ON	2007/05/10 14:00
S29	11	S27 and (photodiode or photodetector or (photo adj diode))	US-PGPUB; USPAT; USOCR; EPO; JPO; DERWENT; IBM_TDB	OR	ON	2007/05/10 14:00
S30	9	rose-kusha.xa.	US-PGPUB; USPAT; USOCR; EPO; JPO; DERWENT; IBM_TDB	OR	ON	2007/05/10 14:04
S31	281	(photodiode or (photo adj diode)) same (trench or hole) and ((impurity or separation) adj region)	US-PGPUB; USPAT; USOCR; EPO; JPO; DERWENT; IBM_TDB	OR	ON	2007/05/10 14:48
S32	127	S31 and @ad<"20030101"	US-PGPUB; USPAT; USOCR; EPO; JPO; DERWENT; IBM_TDB	OR	ON	2007/05/10 15:27

S33	912	(photodiode or (photo adj diode)) same ((trench or hole) and (impurity or (separation adj region)))	US-PGPUB; USPAT; USOCR; EPO; JPO; DERWENT; IBM_TDB	OR	ON	2007/05/10 15:27
S34	430	S33 and @ad<"20030101"	US-PGPUB; USPAT; USOCR; EPO; JPO; DERWENT; IBM_TDB	OR	ON	2007/05/10 15:28
S35	912	(photodiode or (photo adj diode)) same ((trench or hole) and (impurity or (separation adj region)))	US-PGPUB; USPAT; USOCR; EPO; JPO; DERWENT; IBM_TDB	OR	ON	2007/05/10 15:28
S36	430	S35 and @ad<"20030101"	US-PGPUB; USPAT; USOCR; EPO; JPO; DERWENT; IBM_TDB	OR .	ON	2007/05/10 15:28
S37	. 0	S34 not S36	US-PGPUB; USPAT; USOCR; EPO; JPO; DERWENT; IBM_TDB	OR	ON	2007/05/10 15:28
S38	1434	(photodiode or (photo adj diode)) same (trench or hole) and (impurity or (separation adj region))	US-PGPUB; USPAT; USOCR; EPO; JPO; DERWENT; IBM_TDB	OR	ON	2007/05/10 15:37
S39	1	S38 and @ad<"2003"	US-PGPUB; USPAT; USOCR; EPO; JPO; DERWENT; IBM_TDB	OR	ON	2007/05/10 15:32
S40	759	S38 and @ad<"20030101"	US-PGPUB; USPAT; USOCR; EPO; JPO; DERWENT; IBM_TDB	OR	ON	2007/05/10 15:38

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S41	1004	S38 not S36	US-PGPUB;	OR	ON	2007/05/10 15:34
			USPAT; USOCR; EPO; JPO; DERWENT; IBM_TDB			
542	1004	S38 not S36	US-PGPUB; USPAT; USOCR; EPO; JPO; DERWENT; IBM_TDB	OR	ON	2007/05/10 15:34
S43	1004	S38 not S36	US-PGPUB; USPAT; USOCR; EPO; JPO; DERWENT; IBM_TDB	OR	ON	2007/05/10 15:35
S44	329	S40 not S36	US-PGPUB; USPAT; USOCR; EPO; JPO; DERWENT; IBM_TDB	OR	ON	2007/05/10 15:35
S45	281	(photodiode or (photo adj diode)) same (trench or hole) and (impurity or separation) adj region	US-PGPUB; USPAT; USOCR; EPO; JPO; DERWENT; IBM_TDB	OR	ON	2007/05/10 15:40
S46	127	S45 and @ad<"20030101"	US-PGPUB; USPAT; USOCR; EPO; JPO; DERWENT; IBM_TDB	OR .	ON	2007/05/10 15:43
S47	273	(photodiode or (photo adj diode)) same (trench or hole) same (polysilicon or metal) same (polish\$3 remov\$3 etch\$3 CMP)	US-PGPUB; USPAT; USOCR; EPO; JPO; DERWENT; IBM_TDB	OR	ON	2007/05/10 17:18
S48	143	S47 and @ad<"20030101"	US-PGPUB; USPAT; USOCR; EPO; JPO; DERWENT; IBM_TDB	OR	ON	2007/05/10 17:17

S49	2	"2001318155"	US-PGPUB; USPAT; USOCR; EPO; JPO; DERWENT; IBM_TDB	OR	ON	2007/05/10 16:59
S50	171	(photodiode or (photo adj diode)) same (trench or hole) same (polysilicon or metal or conducti\$2) same (polish\$3 remov\$3 etch\$3 CMP) same (wir\$3 connect\$3 interconnect\$3)	US-PGPUB; USPAT; USOCR; EPO; JPO; DERWENT; IBM_TDB	OR	ON	2007/05/10 17:17
S51	80	S50 and @ad<"20030101"	US-PGPUB; USPAT; USOCR; EPO; JPO; DERWENT; IBM_TDB	OR .	ON	2007/05/10 17:19
S52	66	((photodiode or (photo adj diode) (photodetector) (photo-detector)) and sensor) same (trench or hole) same (polysilicon or metal) same (polish\$3 remov\$3 etch\$3 CMP)	US-PGPUB; USPAT; USOCR; EPO; JPO; DERWENT; IBM_TDB	OR	ON	2007/05/10 17:27
S53	31	S52 and @ad<"20030101"	US-PGPUB; USPAT; USOCR; EPO; JPO; DERWENT; IBM_TDB	OR	ON	2007/05/10 17:19
S54	5	((photodiode or (photo adj diode) (photodetector) (photo-detector)) and sensor) same ((trench or hole) with substrate) same (polysilicon or metal) same (polish\$3 remov\$3 etch\$3 CMP) and @ad<"20030101"	US-PGPUB; USPAT; USOCR; EPO; JPO; DERWENT; IBM_TDB	OR	ON	2007/05/10 17:36
S55	7	((photodiode or (photo adj diode) (photodetector) (photo-detector)) and sensor) same ((trench or hole aperture) with substrate) same (polysilicon or metal or conducti\$3) same (polish\$3 remov\$3 etch\$3 CMP) and @ad<"20030101"	US-PGPUB; USPAT; USOCR; EPO; JPO; DERWENT; IBM_TDB	OR	ON	2007/05/10 17:37
S56	361	(photodiode or (photo adj diode)) and array same (impurity or (separation adj region)) and @ad<"20030101"	US-PGPUB; USPAT; USOCR; EPO; JPO; DERWENT; IBM_TDB	OR	ON	2007/05/10 20:11

S57	204	((photodiode or (photo adj diode)) and array) same (impurity or (separation adj region)) and @ad<"20030101"	US-PGPUB; USPAT; USOCR; EPO; JPO; DERWENT; IBM_TDB	OR	ON	2007/05/10 20:14
S58	3	((photodiode or (photo adj diode)) and array) same (impurity with (separation adj region)) and @ad<"20030101"	US-PGPUB; USPAT; USOCR; EPO; JPO; DERWENT; IBM_TDB	OR	ON	2007/05/10 20:17
S59	3	((photodiode or (photo adj diode)) and array) same ((impurity dop\$3) with (separat\$3 adj region)) and @ad<"20030101"	US-PGPUB; USPAT; USOCR; EPO; JPO; DERWENT; IBM_TDB	OR	ON	2007/05/10 20:17
S60	. 11	((photodiode or (photo adj diode)) and array) same ((impurity dop\$3) with ((separat\$3 isolat\$3) adj region)) and @ad<"20030101"	US-PGPUB; USPAT; USOCR; EPO; JPO; DERWENT; IBM_TDB	OR	ON	2007/05/10 20:22
S61	8	((photodiode or (photo adj diode)) and array) with ((impurity dop\$3) with ((separat\$3 isolat\$3) adj region)) and @ad<"20030101"	US-PGPUB; USPAT; USOCR; EPO; JPO; DERWENT; IBM_TDB	ÖR	ON	2007/05/10 20:23
S62	0	((photodiode or (photo adj diode)) and array) same ((impurity dop\$3) same (((separat\$3 isolat\$3) adj region)) with electrical\$2) and @ad<"20030101"	US-PGPUB; USPAT; USOCR; EPO; JPO; DERWENT; IBM_TDB	OR	ON	2007/05/10 20:25
S63	0	((photodiode or (photo adj diode)) and array) same ((impurity dop\$3) same (((separat\$3 isolat\$3) adj region)) with electrical) and @ad<"20030101"	US-PGPUB; USPAT; USOCR; EPO; JPO; DERWENT; IBM_TDB	OR .	ON	2007/05/10 20:25
S64	4	((photodiode or (photo adj diode)) and array) same ((impurity dop\$3) and electrical\$2 same ((separat\$3 isolat\$3) adj region)) and @ad<"20030101"	US-PGPUB; USPAT; USOCR; EPO; JPO; DERWENT; IBM_TDB	OR ·	ON	2007/05/10 20:34

S65	13	((photodiode or (photo adj diode)) and array) same ((impurity dop\$3) and electrical\$2 with ((separat\$3 isolat\$3) with region)) and @ad<"20030101"	US-PGPUB; USPAT; USOCR; EPO; JPO; DERWENT; IBM_TDB	OR	ON	2007/05/10 20:34
S66	1	S64 not S65	US-PGPUB; USPAT; USOCR; EPO; JPO; DERWENT; IBM_TDB	OR	ON	2007/05/10 20:35
S67	10	S65 not S64	US-PGPUB; USPAT; USOCR; EPO; JPO; DERWENT; IBM_TDB	OR	ON	2007/05/10 21:26
S68	57	organic and transistor and (u adj shaped near channel)	US-PGPUB; USPAT; USOCR; EPO; JPO; DERWENT; IBM_TDB	OR	ON	2007/05/10 21:30
S69	. 26	S68 and @ad<"20030101"	US-PGPUB; USPAT; USOCR; EPO; JPO; DERWENT; IBM_TDB	OR	ON	2007/05/10 21:28
S70	1	("5563077").PN.	US-PGPUB; USPAT; USOCR	OR .	OFF	2007/05/10 21:28
S71		organic and transistor and (((u adj shaped) or meandering) near channel)	US-PGPUB; USPAT; USOCR; EPO; JPO; DERWENT; IBM_TDB	OR	ON	2007/05/10 21:37
S72		organic and transistor and (((u adj shaped) or meandering) near channel) and (NAND or NOR)	US-PGPUB; USPAT; USOCR; EPO; JPO; DERWENT; IBM_TDB	OR	ON .	2007/05/10 21:32

S73	546	Fix.in.	US-PGPUB; USPAT; USOCR; EPO; JPO; DERWENT; IBM_TDB	OR .	ON	2007/05/10 21:32
S74	74	Fix-Walter.in.	US-PGPUB; USPAT; USOCR; EPO; JPO; DERWENT; IBM_TDB	OR	ON	2007/05/10 21:33
S75	13	S74 and (((u adj shaped).clm. and organic.clm. ) OFET.clm.)	US-PGPUB; USPAT; USOCR; EPO; JPO; DERWENT; IBM_TDB	OR	ON	2007/05/10 21:33
S76	26	organic and transistor and (((u adj shaped) or meandering) adj channel) and @ad<"20030101"	US-PGPUB; USPAT; USOCR; EPO; JPO; DERWENT; IBM_TDB	OR	ON	2007/05/10 22:03
S77	36	organic and transistor and ((holes interruptions) with (semiconducting adj layer)) and @ad<"20030101"	US-PGPUB; USPAT; USOCR; EPO; JPO; DERWENT; IBM_TDB	OR	ON	2007/05/10 22:26
S78	0	organic and transistor and (((holes interruptions) with (semiconducting adj layer)) same leakage) and @ad<"20030101"	US-PGPUB; USPAT; USOCR; EPO; JPO; DERWENT; IBM_TDB	OR .	ON	2007/05/10 22:26
S79	36	organic and transistor and (((holes interruptions) with (semiconducting adj layer))) and @ad<"20030101"	US-PGPUB; USPAT; USOCR; EPO; JPO; DERWENT; IBM_TDB	OR .	ON	2007/05/10 22:28
S80	36	organic and transistor and (((pattern\$ interruptions) with (semiconducting adj layer))) and @ad<"20030101"	US-PGPUB; USPAT; USOCR; EPO; JPO; DERWENT; IBM_TDB	OR	ON	2007/05/10 22:30

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S81		organic and transistor and (((interruption) with (semiconducting adj layer))) and @ad<"20030101"	US-PGPUB; USPAT; USOCR; EPO; JPO; DERWENT; IBM_TDB	OR	ON	2007/05/10 22:30
S82	28	organic and transistor and (((patterned) with (semiconducting adj layer))) and @ad<"20030101"	US-PGPUB; USPAT; USOCR; EPO; JPO; DERWENT; IBM_TDB	OR	ON	2007/05/10 22:31
S83	983	organic and transistor and (((patterned) with (semiconductor adj layer))) and @ad<"20030101"	US-PGPUB; USPAT; USOCR; EPO; JPO; DERWENT; IBM_TDB	OR	ON	2007/05/10 22:32
S84	288	organic and transistor and (((patterned) with (semiconductor adj layer)) and leakage) and @ad<"20030101"	US-PGPUB; USPAT; USOCR; EPO; JPO; DERWENT; IBM_TDB	OR	ON	2007/05/10 22:35
S85	3	organic and transistor and (((patterned) with (semiconductor adj layer)) with leakage) and @ad<"20030101"	US-PGPUB; USPAT; USOCR; EPO; JPO; DERWENT; IBM_TDB	OR	ON	2007/05/10 22:36
S86	.2	organic and transistor and (((patterned) with (semiconductor adj layer)) with leak\$3 adj current) and @ad<"20030101"	US-PGPUB; USPAT; USOCR; EPO; JPO; DERWENT; IBM_TDB	OR	ON	2007/05/10 22:36
S87	20	("3588635"   "4084173"   "4775880"   "4959430"   "5079614"   "5866938"   "6114732").PN. OR ("6362509"). URPN.	US-PGPUB; USPAT; USOCR	OR	ON	2008/01/21 13:40